

Single Crystal Diamond Tip-Nanoindentation/ Nanoscratching/ Lithography-b

SCDT-NI/NS/L-b

SPECIFICATIONS

Cantilever

These tips are specifically designed for high mechanical loads and scratch testing applications. By using wear-resistant diamond and a board cone angle the contact size is well characterized and stays constant during repeated mechanical measurements. These probes have demonstrated highly repeatable deep (~100nm) indentations into materials such as fused silica and are able to image the indents at high resolution in-situ using the same probe. A gold reflex coating deposited on the detector side of the cantilever to enhance the reflectance of the laser beam.

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a h	short_desc	Unique Probes with Single Crystal Diamond Tip Specially Designed for
SII		Nanoindentation, Nanoscratching, and Lithography

Categories AFM Probes, Diamond

Tags : Hardened/Enhanced Wear Resistance, Nanoindentation and Lithography

Single

Quantity 5

Cantilever Length 125
Cantilever Width 30

Cantilever Thickness 4

Resonant Frequency [kHz] 500, 750, 1000

Force Constant [N/m] 100, 350, 600

Coating Au Reflective

Cantilever Shape Rectangular

Tip 4 Sided Pyramid

Tip Material Diamond

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